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NO. 7723 P. 1

PTO/SB/07 (08-05)

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Application Number See attached Schedule A

Filing Date See attached Schedule A

In re Applicant: Tokyo Ohka Kogyo Co., Ltd.

Art Unit unassigned

Examiner Name unassigned

Attorney Docket Number See attached Schedule A

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Change of Correspondence Address with attached Schedule A (3 pages)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re of Applicant: Tokyo Ohka Kogyo Co., Ltd. Docket No.: See attached Schedule A

Serial No.: See attached Schedule A Art Unit: Not yet designated

Filing Date: See attached Schedule A Examiner: Not yet designated

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313

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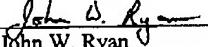
CHANGE OF CORRESPONDENCE ADDRESSES

Applicants respectfully requests the Examiner to change the correspondence address for the following applications as listed in the attached Schedule A to the address associated with the attorney of record:

Customer No.:	38,552		
Individual Name:	John W. Ryan		
Firm Name:	Dechert, LLP		
Address:	1775 I Street, NW		
City:	Washington	State: DC	Zip: 20006
Telephone:	1-202-261-3375		
Fax:	1-202-261-3333		

If necessary, please charge any fees in connection with this submission or credit any overpayments to our Deposit Account No. 50-2787. If you have any questions regarding this submission, please contact the undersigned attorney at the local Washington DC office.

Respectfully submitted,


John W. Ryan
Registration No. 33,771

Date: December 7, 2004

DECHERT, LLP
1775 I Street, N.W.
Washington, DC 20006

276244.1.DC_03

Schedule A
Change of Correspondence Address

Client: Tokyo Ohka Kogyo Co., Ltd
Customer Number: 38,552

NO. 7723 P. 3
US

Attorney Docket: 372106-101

Title: Resist Developer and Resist Pattern Formation Method Using Same

Client: Tokyo Ohka Kogyo Co., Ltd.

Country	Application Number	Filing Date
US	104422,548	24-Apr-2003

Attorney Docket: 372106-102

Title: SILICA-BASED ORGANIC FILM AND METHOD OF
MANUFACTURING THE SAME, AND BASE MATERIAL
COMPRISING ORGANIC FILM

Client: Tokyo Ohka Kogyo Co., Ltd.

Country	Application Number	Filing Date
US	10516,731	10-Jul-2003
US	10780,822	15-Mar-2004

Attorney Docket: 372106-103
Title: POSITIVE TYPE RESIST COMPOSITION AND RESIST

PATTERN FORMATION METHOD

Client: Tokyo Ohka Kogyo Co., Ltd.

Country	Application Number	Filing Date
US	10466,722	14-Jan-2003

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Schedule A

Change of Correspondence Address

Client: Tokyo Ohka Kogyo Co., Ltd

Customer Number: 38552

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NO. 7723

Attorney Docket: 372106-104

Title: POSITIVE TYPE RESIST COMPOSITION AND RESIST
PATTERN FORMATION METHOD

Client: Tokyo Ohka Kogyo Co., Ltd.

Country	Application Number	Filing Date
US	10466,473	14-Jul-2003

Attorney Docket: 372106-105

Title: PHOTORESIST PATTERN AND FORMING METHOD THEREOF

Client: Tokyo Ohka Kogyo Co., Ltd.

Country	Application Number	Filing Date
US	10628,919	29-Jul-2003

Attorney Docket: 372106-106

Title: Positive Type Resist Composition and Resist Pattern Formation
Method Using Same

Client: Tokyo Ohka Kogyo Co., Ltd.

Country	Application Number	Filing Date
US	10467,130	01-AUG-2003

Attorney Docket: 372106-107

Title: BASE MATERIAL FOR LITHOGRAPHY

Client: Tokyo Ohka Kogyo Co., Ltd.

Country	Application Number	Filing Date
US	10648,752	26-Aug-2003

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Schedule A

Change of Correspondence Address
Client: Tokyo Ohka Kogyo Co., Ltd
Customer Number: 38,552

NO. 7723 P. 5

Attorney Docket: 372106-108

Title: Preparation for Nano Material, Metal Oxide Nano Material Formation
Composition Used for the Method, Mold and Metal Oxide Nano Structure

Client: Tokyo Ohka Kogyo Co., Ltd.

Country	Application Number	Filing Date
US	10840,192	06-May-2004

Attorney Docket: 372106-109

Title: Resist Composition

Client: Tokyo Ohka Kogyo Co., Ltd.

Country	Application Number	Filing Date
US	10845,620	13-May-2004

Attorney Docket: 372106-110

Title: Positive Resist Composition and Formation Method of Resist Pattern

Client: Tokyo Ohka Kogyo Co., Ltd.

Country	Application Number	Filing Date
US	10859,904	03-Jun-2004

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Attorney Docket: 372106-111
Title: Positive Resist Composition and Resist Pattern Forming Method
Client: Tokyo Ohka Kogyo Co., Ltd.

Country	Application Number	Filing Date
US	10865,900	10-Jun-2004